

Notice of References Cited		Application/Control No. 10/580,231	Applicant(s)/Patent Under Reexamination EDWIN ET AL.	
		Examiner DANIEL C. MCCRACKEN	Art Unit 1793	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,905,544	06-2005	Setoguchi et al.	117/105
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Venegoni, et al., Parametric study for the growth of carbon nanotubes by catalytic chemical vapor deposition in a fluidized bed reactor, Carbon 2002; 40: 1799-1807.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.